Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/767,768	OGAWA, HIDEHIKO		
Examiner	Art Unit		
Thomas D. Lee	2624		

	SEARCHED					
Class	Subclass	Date	Examiner			
358	1.15, 402, 440	6/7/2005	TDL			
379	100.01	6/7/2005	TDL			
379	100.08	6/7/2005	TDL			
379	100.13	6/7/2005	TDL			
379	100.17	6/7/2005	TDL			
updated		9/15/2005	TDL			
updated		12/2/2005	TDL			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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Interference Search Printout		12/2/2005	TDL	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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